

SEP 25 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/805,620
Confirmation No. 3004
Filing Date March 13, 2001
Inventor Craig M. Carpenter et al.
Assignee Micron Technology Inc.
Group Art Unit 1762
Examiner Eric Fuller
Attorney's Docket No. MI22-1563
Title: Chemical Vapor Deposition Methods

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: 25 Sep 2006

By: _____

James E. Lake
Reg. No. 44,854

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M122-1563		SERIAL NO. 09/805,620	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT: Craig M. Carpenter			
				FILING DATE March 13, 2001		GROUP 1762	
U.S. PATENT DOCUMENTS							
*Examiner's Initials	Document Number	Date	Name	Class	Subclass	Filing Date if Appropriate	
AA	5,338,383	08/1994	Kawata et al.				
AB	5,746,834	05/1998	Hanley, Thomas M.				
AC	5,792,272	08/1998	van Os et al.				
AD	5,851,294	12/1998	Young et al.				
AE	6,890,686 B2	05/2005	Sargiannis et al.				
AF							
AG							
AH							
AI							
FOREIGN PATENT DOCUMENTS							
	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
AJ	JP 20-46723	02/1990	JP (Kato et al.)				X
AK							
AL							
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)							
	AM						
	AN						
	AO						
EXAMINER		DATE CONSIDERED					
<small>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>							